
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Wu et al.

Attorney Docket No.:
NOVLP091/NVLS-2889

Application No.: 10/820,525

Examiner: Maldonado, Julio J.

Filed: April 7, 2004

Group: 2823

Title: METHODS FOR PRODUCING LOW-K
CDO FILMS WITH LOW RESIDUAL
STRESS

Confirmation No: 8337

CERTIFICATE OF EFS-WEB TRANSMISSION

I hereby certify that this correspondence is being transmitted electronically through EFS-WEB to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450 on November 9, 2009.

Signed: /Latonia Ervin/
Latonia Ervin

AMENDMENT F

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated August 7, 2009 in the above-identified application, please amend the application as follows:

A Listing of the Claims begins on page 2 of this paper.

Remarks/Arguments are on page 7 of this paper.